IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

pólication Serial No.10/075,193 QEMARY OF Iling Date February 13, 2002 Inventor.......Shenlin Chen et al. Assignee Micron Technology, Inc.

Title: Methods of Forming a Capacitor Structure

RESPONSE TØ JUNE 4, 2003 FINAL ACTION TO ACCOMPANY RCE FILING

Mail Stop RCE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

From:

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<u>AMENDMENTS</u>

Introductory Comments

In response to the Office Action dated June 4, 2003, applicant amends and amarks as follows.